

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/812,765	ARAI ET AL.	
Examiner	Art Unit	
Wen-Ying P. Chen	2871	

	SEARCHED				
Class	Subclass	Date	Examiner		
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INT	INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner		
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
Citations search of tagged references	12/15/2005	WPC		
349/112 combined with key word search of all databases in EAST	12/15/2005	WPC		
Review previously cited references	12/15/2005	WPC		